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FROM: James P. Zeller
RE: 10/722, 814 - Atty Docket : 29936/39765
PAGES (INCLUDING THIS PAGE): 6

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Dated: February 17, 2006

Signature: 

James P. Zeigler

Docket No.: 29936/39765
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Cha Deok Dong et al.

Application No.: 10/722,814

Confirmation No.: 9355

Filed: November 26, 2003

Art Unit: 1765

For: METHOD OF FORMING GATE ELECTRODE
IN SEMICONDUCTOR DEVICE

Examiner: D. Vu Nguyen Deo

AMENDMENT AFTER FINAL REJECTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the official action dated December 21, 2005, finally rejecting claims 1-3 and 5-8, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.